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Docket No.: GR 00 P 1583

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By: Am. P. 2 Date: June 19, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Klaus Lowack et al.

Applic. No.: 09/817,963

Filed : March 27, 2001

Title : Method for the Metalization of an Insulator and/or Dielectric

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TC 1700

P R E L I M I N A R Y A M E N D M E N T

Hon. Commissioner of Patents,
Washington, D. C. 20231

S i r :

Preliminary to examination kindly amend the above-identified application as follows:

In the Translated Specification:

Page 1, between lines 4 and 6, insert

-- Background of the Invention:

Field of the Invention: --.

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